



PATENT

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Bailey III et al.

Attorney Docket No.: LAM1P123/P0557

Application No.: 09/470,236

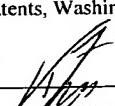
Examiner: Alejandro Mulero, L.

Filed: November 15, 1999

Group: 1746

Title: PLASMA PROCESSING SYSTEM WITH
DYNAMIC GAS DISTRIBUTION CONTROLCERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Assistant Commissioner for Patents, Washington, DC 20231 on January 26, 2001.

Signed: 

Ramin Mahboubian

AMENDMENT TRANSMITTALAssistant Commissioner for Patents
Washington, DC 20231

Sir:

Transmitted herewith is an Amendment in the above-identified application.

The fee has been calculated as shown below.

	Claims After Amendment		Highest Previously Paid For	Present Extra	Small Entity Rate Fee	Large Entity Rate Fee
Total Claims	37	MINUS	37	00	x 9 =	x 18 =
Independent Claims	03	MINUS	03	00	x 40 =	x 80 =
Multiple Dependent Claim Present and Fee Not Previously Paid					\$135.00	\$270.00
				Total	\$	\$0

- Applicant(s) hereby petition for a one-month extension(s) of time to respond to the aforementioned Office Action.
- Applicant(s) believe that no (additional) Extension of Time is required; however, if it is determined that such an extension is required, Applicant(s) hereby petition that such an extension be granted and authorize the Commissioner to charge the required fees for an Extension of Time under 37 CFR 1.136 to Deposit Account No. 500388.
- Enclosed is our Check No. 10184 in the amount of \$110.00 to cover the additional claim fee and/or extension of time fees.
- Please charge the required fees, or any additional fees required to facilitate filing the enclosed response, to Deposit Account No. 500388 (Order No. LAM1P123).

Respectfully submitted,
BEYER WEAVER & THOMAS, LLP
Ramin Mahboubian
Reg. No. 44,890P.O. Box 778
Berkeley, CA 94704-0778RECEIVED
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CONTROL

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Signed: 

Printed Name: Ramin Mahboubian

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AMENDMENT A

Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

In response to the Office Action dated September 26, 2000, please amend the above-identified patent application as follows:

IN THE CLAIMS:

Please AMEND claims as follows:

A1₁>
1. (Once Amended) A plasma processing system, said plasma processing system comprising:

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01 FC:115

110.00 OP